

**Notice of References Cited**

Application/Control No.

09/715,935

Applicant(s)/Patent Under  
Reexamination  
BI ET AL.

Examiner

KELLY STOUFFER

Art Unit

1792

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	K	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Allen et al. "Abstract: Laser chemical vapor deposition of metals and insulators" J. Vac. Technol., 16(2), Mar/Apr 1979, p 431.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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